

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Cheng, et al.

Attorney Docket:

TSM03-0549

Filed:

Herewith

Examiner:

TBD

Serial No.:

10/749,080

Art Unit:

TBD

For:

Depletion-Merged FET Design in Bulk Silicon

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

The Applicant wishes to bring to the attention of the Patent and Trademark Office the information noted on the enclosed form PTO/SB/08A & 08B that may be considered material to the examination of the above-identified application.

No fee is due at this time, as this Information Disclosure Statement is being filed pursuant to 37 C.F.R. § 1.97(b)(3), before the mailing of a first Office action on the merits.

Pursuant to 37 CFR 1.98(a)(2)(i), as amended, copies of U.S. Patents cited are not being submitted. However, Applicant has included copies of any non-patent literature.

Respectfully submitted,

Le April 04
Date

Ý

James C. Kesterson

Attorney for Applicant

Reg. No. 25,882

Slater & Matsil, L.L.P. 17950 Preston Rd., Suite 1000 Dallas, TX 75252 (972) 732-1001 (phone) (972) 732-9218 (fax) APR 0 9 2004 4 Apr 7RANE

PTO/SB/08a (08-03)
Approved for use through 07/31/2006. OMB 0651-0031
U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

der the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number.

Complete if Known Substitute for form 1449A/PTO 10/749,080 **Application Number** INFORMATION DISCLOSURE Filing Date December 30, 2003 STATEMENT BY APPLICANT First Named Inventor Cheng et al. Art Unit TBD (Use as many sheets as necessary) TBD Examiner Name 2 Sheet Attorney Docket Number TSM03-0549

	U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No.1	Document Number Number - Kind Code ^{2 (# known)}	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear		
		US- 6,538,277 B2	03-25-2003	Sung et al.			
		US- 6,566,706 B1	05-20-2003	Wang et al.			
	<u> </u>	US-					
		US-					
<u></u>		US-					
	<u> </u>	US-					
		US-					
	<u> </u>	US-					
		US-					
		US-					
		US-					
		US-					
		US-					
		US-					
		US-					
		US-					
		US-					
		US-					
		US-					
		US-					

	FOREIGN PATENT DOCUMENTS						
Evaminer		Foreign Patent Document	Publication Date	Name of Patentee or	Pages, Columns, Lines,		
Initials*		MM-DD-YYYY	Applicant of Cited Document	Where Relevant Passages or Relevant Figures Appear	T ⁶		
	·					-	
				•			
	<u> </u>						
,	ļ						
				1			

Examiner	 Date	
Signature	Considered	<u></u>

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹Applicant's unique citation designation number (optional). ²See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.

Translation is attached:
This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

PTO/SB/08b (08-03)

Approved for use through 06/30/2006. OMB 0651-0031

U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number.

Substitute for form 1449B/PTO				Complete if Known		
				Application Number	10/749,080	_
INFORMATION DISCLOSURE				Filing Date	December 30, 2003	
STATEMENT BY APPLICANT (Use as many sheets as necessary)				First Named Inventor	Cheng et al.	
			-4141	Art Unit	TBD	
				Examiner Name	TBD	
Sheet	2	of	2	Attorney Docket Number	TSM03-0549	

		NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
		ERTL, FRANK et al., "Vertical transistors with ultra-short channel lengths," Fundamental research in semiconductor electronics - Annual Report 2000, (2000) pp. 90-91.	
		GÖHLER, LUTZ. et al., "A Compact Model for Depletion MOSFETs in Smart Power Applications Including Source and Drain Resistance," (Date Unknown) 5 pages.	
The state of the s		MANNERS, DAVID, "Infineon Looks to NROM," Electronics Weekly, (May 28, 2001) http://www.reed-electronics.com/electronicnews.	
		SHEPARD, KENNETH, et al., "Static Noise Analysis for Digital Integrated Circuits in Partially-Depleted Silicon-On-Insulator Technology," Proceedings of the Design Automation Conference, Los Angeles, California, (June 2000) 4 pages.	
		STOCKINGER, MICHAEL, "2.3 Drain-Induced Barrier Lowering," (January 05, 2000) http://www.iue.tuwien.ac.at/phd/stockinger/node15.html .	

Examiner Date	e
Signature	sidered

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

'Applicant's unique citation designation number (optional). 'Applicant is to place a check mark here if English language Translation is attached. This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

APR 0 9 2004 \$

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Cheng, et al.

Docket No.:

TSM03-0549

Serial No.:

10/749,080

Art Unit:

TBD

Filed:

December 30, 2003

Examiner:

TBD

For:

Depletion-Merged FET Design in Bulk Silicon

Certificate of Mailing via First Class Mail (37 C.F.R. § 1.8(a))

Date of Deposit:

April 6, 2004

I hereby certify that the below listed correspondence is being deposited with the United States Postal Service on the date indicated above as first class mail in an envelope addressed to: Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450.

Certificate of Mailing via First Class Mail (1 page) Information Disclosure Statement (1 page) Form PTO/SB/08A & 08B with 7 References Cited (2 pages) Copy of 5 References Cited Return Postcard

Respectfully submitted,

Engeldahl

Kristy Engeldahl

Legal Assistant

Slater & Matsil, L.L.P. 17950 Preston Rd., Suite 1000 Dallas, TX 75252

Tel: 972-732-1001 Fax: 972-732-9218